

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Johannes BAUR et al.

Serial No.: 10/529,625

Filed: November 18, 2005

For: Radiation-Emitting Semiconductor Component
and Method for the Production thereof

Examiner: Wilson, Scott R.
Group Art: 2826

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

S I R:

In compliance with the duty of disclosure under 37 C.F.R. §1.56 and in accordance with the practice under 37 C.F.R. §§1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO/SB/08a. Copies of the listed documents are also enclosed.

Each item of information contained in the Information Disclosure Statement was first cited in an Office Action received from the Japanese Patent Office (copy of English translation enclosed) in a counterpart Japanese patent application not more than three months prior to the filing of the Information Disclosure Statement.

The remaining document (WO 01/61764) listed on the Japanese Office Action was already listed in the Information Disclosure Statement that was submitted on March 30, 2005.

